



Bond-breaking induced Lifshitz transition in robust Dirac semimetal VAl_3

Yiyuan Liu^a, Yu-Fei Liu^a, Xin Gui^b, Cheng Xiang^a, Hui-Bin Zhou^a, Chuang-Han Hsu^{c,d}, Hsin Lin^e, Tay-Rong Chang^{f,g,h}, Weiwei Xie^b, and Shuang Jia^{a,i,j,k,1}

^aInternational Center for Quantum Materials, School of Physics, Peking University, Beijing 100871, China; ^bDepartment of Chemistry, Louisiana State University, Baton Rouge, LA 70803; ^cDepartment of Physics, National University of Singapore, Singapore 117542; ^dCentre for Advanced 2D Materials and Graphene Research Centre, National University of Singapore, Singapore 117546; ^eInstitute of Physics, Academia Sinica, Taipei 11529, Taiwan; ^fDepartment of Physics, National Cheng Kung University, Tainan 701, Taiwan; ^gCenter for Quantum Frontiers of Research & Technology, National Cheng Kung University, Tainan 701, Taiwan; ^hPhysics Division, National Center for Theoretical Sciences, Hsinchu 30013, Taiwan; ⁱCollaborative Innovation Center of Quantum Matter, Beijing 100871, China; ^jCAS Center for Excellence in Topological Quantum Computation, University of Chinese Academy of Sciences, Beijing 100190, China; and ^kQuantum Materials and Devices Division, Beijing Academy of Quantum Information Sciences, Beijing 100193, China

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Topological electrons in semimetals are usually vulnerable to chemical doping and environment change, which restricts their potential application in future electronic devices. In this paper, we report that the type-II Dirac semimetal VAl_3 hosts exceptional, robust topological electrons which can tolerate extreme change of chemical composition. The Dirac electrons remain intact, even after a substantial part of V atoms have been replaced in the $\text{V}_{1-x}\text{Ti}_x\text{Al}_3$ solid solutions. This Dirac semimetal state ends at $x = 0.35$, where a Lifshitz transition to p -type trivial metal occurs. The V–Al bond is completely broken in this transition as long as the bonding orbitals are fully depopulated by the holes donated from Ti substitution. In other words, the Dirac electrons in VAl_3 are protected by the V–Al bond, whose molecular orbital is their bonding gravity center. Our understanding on the interrelations among electron count, chemical bond, and electronic properties in topological semimetals suggests a rational approach to search robust, chemical-bond-protected topological materials.

Dirac electron | Lifshitz transition | electron count | chemical bond

Topological semimetals (TSMs) host relativistic electrons near band-crossing points in their electronic structures (1–3). These electrons' low-energy excitation obeys the representations of Dirac equation in particle physics, and, therefore, they are dubbed as Weyl and Dirac fermions. The topologically protected electrons are highly mobile because their topological state is robustly against small local perturbations. In contrast, the chemical potential in TSMs is very sensitive to small change of composition and external environment. This tiny defect may depopulate electrons away from the topological band. This vulnerability limits the TSMs' potential application in future electronic devices.

Here, we report robust topological electrons in Dirac semimetal (DSM) VAl_3 , whose electronic structure can tolerate an extreme chemical composition change. We find that the $\text{V}_{1-x}\text{Ti}_x\text{Al}_3$ solid solutions feature standard transport behaviors of DSM, even after a substantial part of vanadium (V) atoms (35%) have been replaced. Titanium (Ti) substitution induces a Lifshitz transition from n -type DSM to p -type trivial metal, as long as the V–Al bond is completely broken. This Lifshitz transition is controlled by the covalent V–Al bond, which shields the Dirac electrons robustly.

V and Ti trialuminide crystallize in a same structure which is built from the arrangement of the Al_{12} cuboctahedra containing V/Ti atoms (see Fig. 4, *Inset*). They belong to a group of polar intermetallics in which strong metallic bonding occurs within the covalent partial structure (4–6). Previous studies on their band structure and molecular orbitals have clarified that this crystal structure is stabilized by a "magic number" of 14 electrons per transition metal when a pseudogap occurs in the density of states (DOS) (7–11). Recent theoretical work demonstrated that there

exist a pair of tilted-over Dirac cones in the pseudogap in the energy-momentum space slightly above the Fermi level (E_f) of VAl_3 (12, 13). The tilted-over Dirac cones host type-II Lorentz-symmetry-breaking Dirac fermions (14, 15), which can give rise to many exotic physical properties, such as direction-dependent chiral anomaly and Klein tunneling in momentum space (16, 17). Very recently, the Fermi surface and the topological planar Hall effect (PHE) in VAl_3 were illustrated in experiment (13, 18). So far, no relevant study has considered the interrelations among electron count, chemical bond, and topological properties in VAl_3 .

In this paper, we focus on the crystal structure and electronic properties of the isostructural solid solutions of $\text{V}_{1-x}\text{Ti}_x\text{Al}_3$, in which the electron count changes from 14 to 13. We observe a V–Al bond-breaking-induced lattice distortion. Concomitantly, the Hall signal changes from n type to p type at $x = 0.35$. Further investigation reveals that the topological properties such as PHE in VAl_3 remain intact after substantial Ti substitution, until a Lifshitz transition occurs. By performing electronic-structure calculation with the emphasis on the crystal orbital Hamilton population (COHP), we reveal that the maximizing bonds—in particular, the interplanar V–Al bond—are responsible for the structure distortion. The bond formation attempts to lower the DOS at E_f and protects the type-II Dirac fermions when x is

Significance

Understanding the relation between crystal structure and electronic properties is crucial for designing new quantum materials with desired functionality. So far, controlling a chemical bond is less considered as an effective way to manipulate the topological electrons. In this paper, we show that the V–Al bond acts as a shield for protecting the topological electrons in Dirac semimetal VAl_3 . The Dirac electrons remain intact in the $\text{V}_{1-x}\text{Ti}_x\text{Al}_3$ solid solutions, even after a substantial part of V atoms have been replaced. A Lifshitz transition from Dirac semimetal to trivial metal occurs as long as the V–Al bond is completely broken. Our finding highlights a rational approach for designing new quantum materials via controlling their chemical bond.

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¹To whom correspondence may be addressed. Email: gwjljshuang@pku.edu.cn.

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less than 0.35. The V–Al antibonding orbital builds up the Dirac electron band, which is fully depopulated as long as the Lifshitz transition occurs. The relationship among the structure, electron count, and electronic properties in various TSMs (19–21) has been considered, but the influence of the presence or absence of a chemical bond on topological electrons is less pondered (22). Our finding highlights a chemical-bonding gravity center (23) of topological electrons, in particular, TSMs. Understanding this chemical-protection mechanism in various TSMs will help to develop more robust electronic devices, which may have potential application in the future.

Results

We firstly demonstrate the electronic properties of $V_{1-x}Ti_xAl_3$. Fig. 1 shows the Hall resistivity (ρ_{yx}) with respect to the external magnetic field (H) at different temperatures for representative samples. VAL_3 is a n -type semimetal whose ρ_{yx} is large and negatively responsive to field (18). ρ_{yx} is not linearly dependent on H below 50 K, indicating that two types of carriers coexist. If we adopt a rigid-band approximation, a small Ti substitution (3.5%) is expected to compensate the destitute conduction electrons in VAL_3 and leads to a n - p transition. Surprisingly, the profile of ρ_{yx} remains almost intact after 35% of V atoms are replaced. We find a robust semimetal state in VAL_3 which can tolerant large chemical composition change.

This semimetal state ends at $x = 0.35$. When $x = 0.4$, ρ_{yx} is very small because the lowly mobile electrons and holes are compensated. Yet, we can discern that the ρ_{yx} is positively dependent on H at 300 K, but negatively dependent on H at 2 K, indicating a n - p transition onsite. When x is more than 0.4, the alloy becomes a p -type metal, showing a small and linear, temperature-independent ρ_{yx} .

We then investigated the PHE in $V_{1-x}Ti_xAl_3$, which is known as an evidence of existing Dirac fermions (18, 24). The planar Hall resistivity (ρ_{yx}^{PHE}) and anisotropic magneto-resistivity

(ρ_{xx}^{PHE}) in DSMs can be described as the following formula (24, 25):

$$\rho_{yx}^{PHE} = -\Delta\rho_{chiral}\sin\theta\cos\theta, \quad [1]$$

$$\rho_{xx}^{PHE} = \rho_{\perp} - \Delta\rho_{chiral}\cos2\theta, \quad [2]$$

where ρ_{\perp} and ρ_{\parallel} are the resistivity for current perpendicular and parallel to the magnetic-field direction, respectively; $\Delta\rho_{chiral} = \rho_{\perp} - \rho_{\parallel}$ gives the anisotropy in resistivity induced by chiral anomaly. A previous study showed large PHE in VAL_3 (18), and, here, we focus on its change when Ti atoms are substituted. As shown in Fig. 2, the ρ_{yx}^{PHE} and ρ_{xx}^{PHE} show explicit periodic dependence on θ , which can be well-fitted by using Eqs. 1 and 2 when x is less than 0.35. Remarkably, the angular dependent ρ_{yx}^{PHE} and ρ_{xx}^{PHE} suddenly drop to almost zero at $x = 0.35$, which is coincident with the n - p transition. We extract $\Delta\rho_{chiral}$ and ρ_{\perp} for each x , as shown in Fig. 3.

The carrier concentration (n and p for electron and hole, respectively) and mobility (μ) for $V_{1-x}Ti_xAl_3$ are obtained by fitting the field-dependent resistivity and ρ_{yx} at different temperatures. As shown in Fig. 3, the carrier concentration in the V-rich semimetal region is nearly invariant as x increases from 0 to 0.3, while the mobility is relatively large during the process. As comparison, because the carrier density and electron scattering are governed by increasing charge defects (26) in topological trivial alloys in the Ti-rich region, the hole mobility drops significantly when x changes from 1 to 0.55. Concomitant with the n - p transition, the $\Delta\rho_{chiral}$ and ρ_{\perp} dramatically drop to almost zero when x is more than 0.35. Previous studies suggested that the PHE and angular-dependent resistivity are determined by the Berry curvature in nonmagnetic TSMs (25, 27). Our observation reveals that the n - p transition at $x = 0.35$ is a topological transition from a DSM to a trivial metal.

The unusual evolution of electronic properties in the isostructural solutions motivated us to examine their crystal-structure

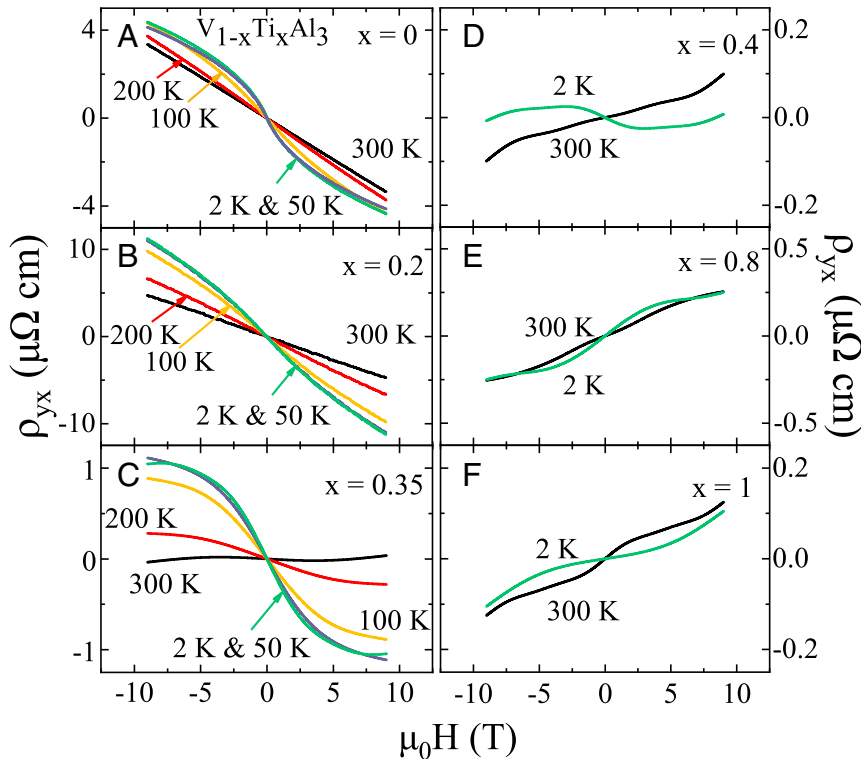


Fig. 1. Field-dependent Hall resistivity (ρ_{yx}) at different temperatures for representative samples in $V_{1-x}Ti_xAl_3$. (A–C) $x = 0$ (A), 0.2 (B), and 0.35 (C) at 2 K, 50 K, 100 K, 200 K, and 300 K. The data at 2 K (green) and 50 K (purple) are nearly identical. (D–F) $x = 0.4$ (D), 0.8 (E), and 1 (F) at 2 K and 300 K.

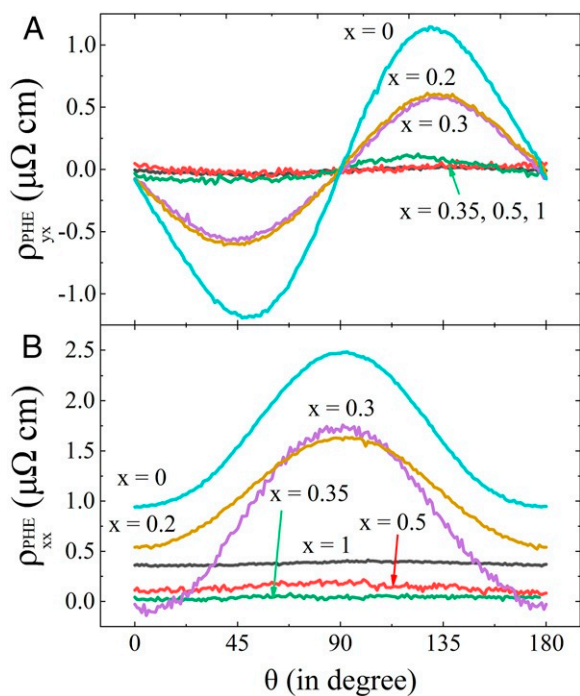


Fig. 2. Planar Hall resistivity (ρ_{yx}^{PHE}) (A) and anisotropic magneto-resistivity (ρ_{xx}^{PHE}) (B) with respect to the angle θ in a magnetic field of 5 T at 2 K for representative samples in $V_{1-x}\text{Ti}_x\text{Al}_3$.

change. Before doing any characterization, we can easily distinguish the rod-like single crystals of VAl_3 from the plate-like TiAl_3 at first sight (Fig. 4, *Insets*). The square plate of TiAl_3 shows glossy (001) facets, and such crystal shape is commonly observed in the compounds composed by slender, tetragonal unit cells. As comparison, the rod-like crystals of VAl_3 have four glossy (110) rectangle facets. Fig. 4, *Insets* show that the crystal shape evolves from a flat plate for $x = 1$, to a three-dimensional chunk for $x = 0.35$, and then to a long rod for $x = 0$. Moreover, the lattice parameters a , c and the ratio of c/a shrink linearly with respect to x when x is more than 0.35, but they change accelerately when x is less than 0.35 (Fig. 4 and *SI Appendix*, Fig. S4). This curious nonlinear change is less than 2%, but it cannot be ascribed to a chemical pressure effect coming from the different size of V and Ti atoms. Contrary to our expectation, the crystal structure is seriously distorted for $x < 0.35$, whereas the electrical transport properties remain intact in this region. In the following part, we will prove that a chemical bond breaking plays a crucial role in the evolution of electronic properties and crystal structure.

Discussion

The crystal structures and the pseudogap in various transition metal trialuminide (TAl_3) have attracted much attention in chemistry (28–32). Yannello and colleagues (33–35) suggested a bonding picture in which each T atom is connected by 4 T–T sigma bonds through the T–Al supporting (*SI Appendix*, Fig. S1). Therefore, the electron count needs $18 - 4 = 14e^-$ to achieve a closed-shell configuration. Ironically, TiAl_3 , as the prototype of this crystal structure, fails to fulfill the criteria because it has only $13e^-$ per formula. We expect a transition from semimetal to metal in $V_{1-x}\text{Ti}_x\text{Al}_3$, but the relationship among electron count, structural distortion, and electronic properties needs further elaboration in theory.

To shed light on the relation between electron count and chemical bond, we compared the electronic structures between

TiAl_3 and VAl_3 . As illustrated in Fig. 5, the lone pair of electrons from V atoms make the chemical-bonding state and the valence band in momentum space just fully filled at the same time. This indicates that 14 valence electrons ($5 + 3 \times 3$ for VAl_3) optimize the bonding in this structure. By reducing one electron, VAl_3 degrades from fully saturated bonding state to partially saturated state for TiAl_3 . To clarify the orbital contributions, a schematic picture based on the molecular perspective of TiAl_3 and VAl_3 is also presented in Fig. 5. The d orbitals on transition metals (Ti or V) split into $a_{1g}(d_{z^2})$, $b_{1g}(d_{x^2-y^2})$, $e_g(d_{xz}, d_{yz})$, and $b_{2g}(d_{xy})$, with the E_f locating between e_g and b_{2g} . Interestingly, the orbital splitting between $e_g(d_{xz}, d_{yz})$ and $b_{2g}(d_{xy})$ significantly reduces as long as the band inversion occurs between $a_{1g}(d_{z^2})$ and $b_{1g}(d_{x^2-y^2})$ from Γ point to Z point in the Brillouin zone (BZ) (see Fig. 7). Given the above, there exists a covalent V–Al bond in VAl_3 which generates a pseudogap between e_g and b_{2g} orbitals, and that gap is minimized at the Z point in the BZ. The related molecular orbitals in VAl_3 and TiAl_3 are shown in *SI Appendix*, Fig. S3.

Fig. 6 shows the change of the interplanar T–Al(II) and inner-planar T–Al(I) bond length and the Al(II)–T–Al(II) bond angle for the whole series. Although both of the T–Al(I) and T–Al(II) bonds elongate when x increases, the T–Al(II) bond changes much more than the T–Al(I) bond for $x < 0.35$, and this change makes the Al(II)–T–Al(II) bond angle much wider for $x < 0.35$. Combining the COHP calculation in Fig. 5, we derive that the T–Al(II) bond plays a crucial role because it has more adjustable length and bonding orientation compared with the weak Al(I)–Al(II) bond and rather stable V–Al(I) bond. The Ti substitution successively weakens the V–Al(II) bond until $x = 0.35$, beyond which the bond is fully broken.

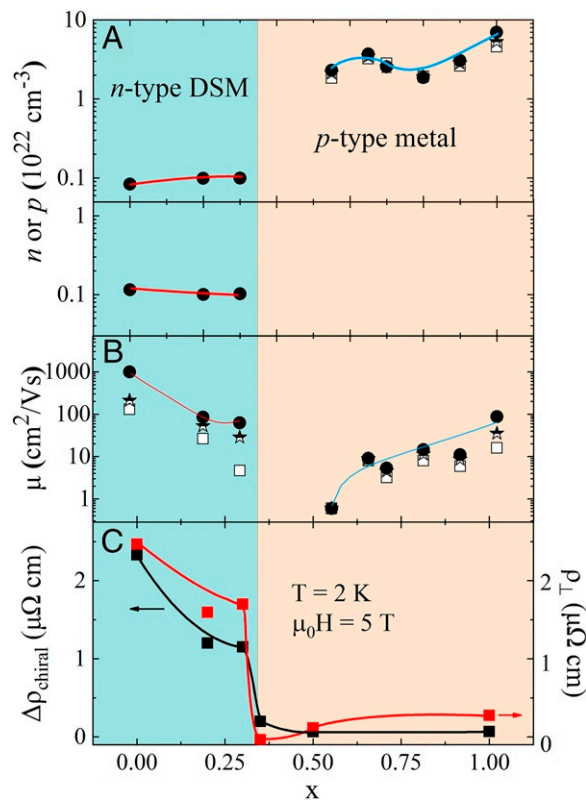


Fig. 3. (A and B) Carrier density (A) and mobility (B) for $V_{1-x}\text{Ti}_x\text{Al}_3$. The solid circles, semisolid stars, and open squares represent the data at 2 K, 150 K, and 300 K, respectively. (C) $\Delta\rho_{\text{chiral}}$ and ρ_{\perp} in a magnetic field of 5 T at 2 K.

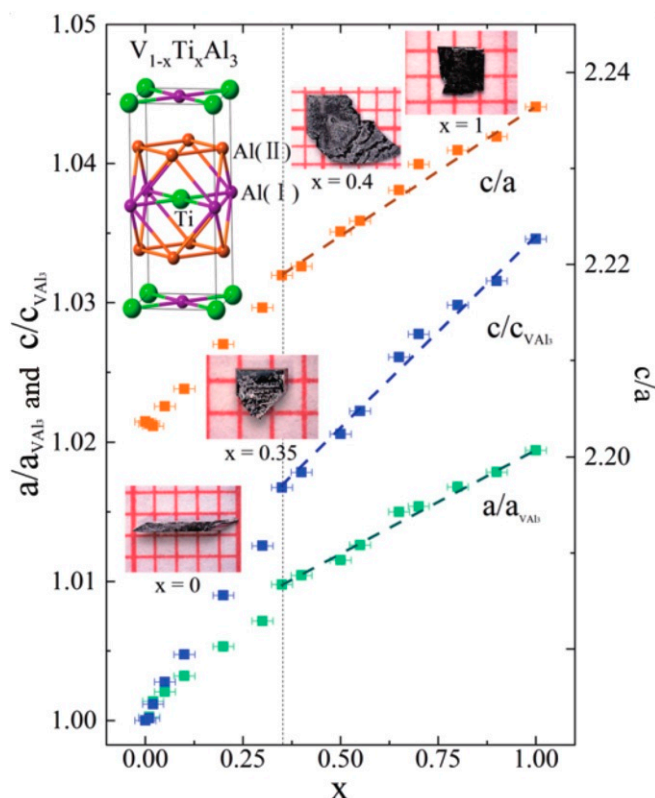


Fig. 4. Lattice parameters (a and c) for $V_{1-x}Ti_xAl_3$. The error bar of x is estimated as $\pm 2\%$, while the error bar of a and c ($< 3 \times 10^{-3} \text{ \AA}$) is smaller than the square data point. The straight dashed lines are guides to the eye. Inset in the top left corner shows the unit cell of $TiAl_3$. Insets from left to right show photos of the single crystals for $x = 0, 0.35, 0.4$, and 1 , respectively.

The change of the crystal shape in $V_{1-x}Ti_xAl_3$ reflects the bond breaking as well. Remember that all of the crystals form in molten Al, so the V–Al(II) dangling bonds should attract more atoms along the c axis for $x < 0.35$. Because the facets of crystals always intent to have fewer dangling chemical bonds, the strong V–Al(II) bond gives rise to the rod-like shape of VAL_3 single crystals.

The bond-breaking scheme above naturally explains the unusual change of the electronic properties in $V_{1-x}Ti_xAl_3$.

Remember that the Lifshitz transition point ($x = 0.35$) divides the whole series into metal and semimetal regions in which the crystal structure and the electronic transport properties change in different ways (Figs. 3 and 4). We focus on the semimetal region in which the topological electrons remain intact, in defiance of the large change of the unit cell. We check the band structure of VAL_3 in which two conduction bands (CB1 and CB2) and two valence bands (VB1 and VB2) are near the E_f (Fig. 7). The conduction band CB1 crosses with the valence band VB1 along the $\Gamma - Z$ direction, forming the Dirac nodes near the Z point, which host the highly mobile Dirac electrons. Another hole pocket of VB2 emerges along the $\Sigma_1 - Z$ direction below 15 meV of the E_f . Although these bands are formed by the hybridization of different orbitals, we can sleuth out their main component atomic orbitals by the symmetry in k space. The cloverleaf-shaped electron pocket of CB1 along the diagonal direction mainly stems from the $b_{2g}(d_{xy})$ orbital, while the hole pocket of VB2 along the straight direction mainly stems from the degenerated $e_g(d_{xz}, d_{yz})$ orbitals. On the other hand, the large dispersion along the k_z direction in the VB1 top inherits the p_z orbital of Al and $a_{1g}(d_{z^2})$ orbital of V. This rough estimation is consistent with our molecular energy-level diagram on the Γ and Z points (Fig. 5). The $n-p$ transition occurs as long as the electrons fully depopulate the b_{2g} orbital. This bond breaking corresponds to the Lifshitz transition, in which the E_f leaves the CB1 bottom and starts to touch the VB2 top. The V–Al bond is fully broken, and the system degenerates to a trivial p -type metal as long as the VB2 starts to be populated when x is more than 0.35.

Hoffmann (23) suggested that maximizing bond, acting as a reservoir to store electrons, always makes every effort to lower the DOS at the E_f . When x is less than 0.35 in $V_{1-x}Ti_xAl_3$, the bond formation demands extra electrons, which compensates the V substitution, and, therefore, the E_f is pinned on the VB2 top. Vice versa, the Ti substitution in VAL_3 breaks the V–Al bond at first, and such a bond-breaking process acts as a buffer to retard the Lifshitz transition. In the scenario of the molecular orbitals, the covalent bond of V–Al(II) acts as the bonding gravity center (23) of the topological electrons in VAL_3 . The type-II Dirac electrons are protected by the V–Al bond.

Conclusion

We observe robust Dirac electrons which are protected by the V–Al chemical bond in the $V_{1-x}Ti_xAl_3$ solid solutions. When Ti atoms substitute V atoms, the V–Al bond acts as a

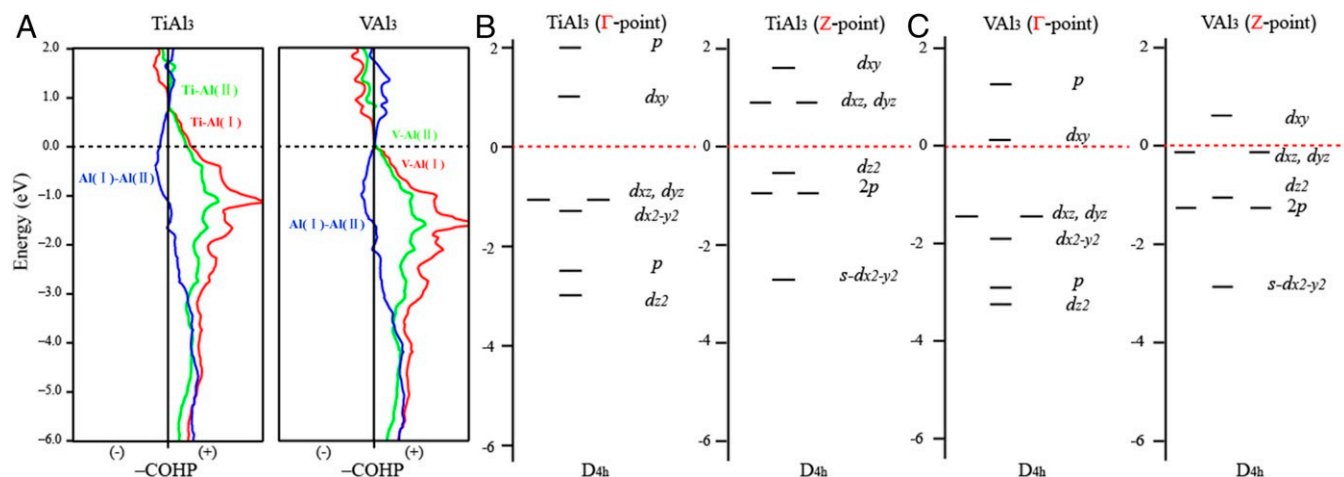


Fig. 5. (A) COHP for $TiAl_3$ and VAL_3 . (B and C) Molecular energy-level diagrams at Γ and Z points for $TiAl_3$ and VAL_3 , respectively.

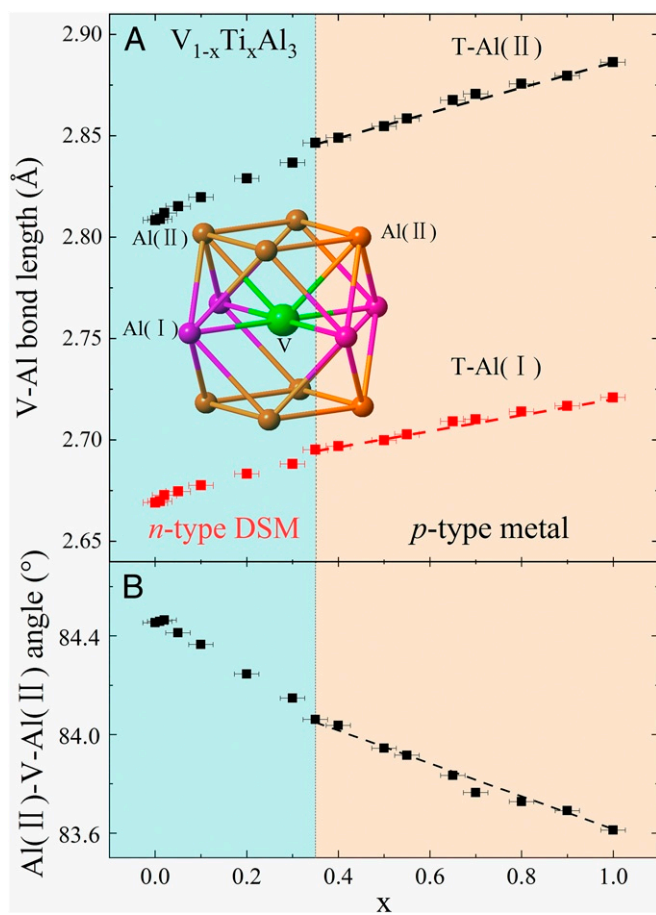


Fig. 6. T-Al(I) and T-Al(II) bond length (A) and Al(II)-T-Al(II) bond angle (B) for $V_{1-x}Ti_xAl_3$. A, Inset shows the V-centered Al_{12} cuboctahedra. The straight dashed lines are guides for the eye.

shield for the Dirac electrons in VAL_3 . As long as the V-Al bond is completely broken, the *n*-type DSM degenerates to *p*-type trivial metal through a Lifshitz transition. We further infer that this kind of chemical-bond protection is likely unique in type-II TSMs which host the tilted-over Dirac cones. In such band structure, the bond formation may partially populate the Dirac cone, which acts as a dispersive part around the molecular-orbital-energy center. Finally, we suggest that the manipulation of chemical bond in topological materials bears more consideration for designing the functional quantum materials. Our future study in quantum materials will involve various chemical-bonding models and electron-counting rules.

Materials and Methods

Synthesis. Single crystals of $V_{1-x}Ti_xAl_3$ were grown via a high-temperature-solution method with Al as the flux (36). The raw materials of V pieces (99.99%), Ti powders (99.99%), and Al ingot (99.9%) were mixed together in a molar ratio of V:Ti:Al = $x : 1 - x : 49$ and then placed in an alumina crucible, which was sealed in a fused silica ampoule under partial argon atmosphere. The mixtures were heated up to 1,323 K for 10 h to ensure the homogeneity. Then, the crystal-growth process involved the cooling from 1,323 to 1,023 K over a period of 5 days, followed by decanting in a centrifuge. The typical size of $V_{1-x}Ti_xAl_3$ series crystals varies from $2 \times 2 \times 0.1$ mm³ for plate-like to $0.5 \times 0.5 \times 5$ mm³ for rod-like.

Composition and Structure Determinations. Powder X-ray diffraction (XRD) measurements were carried out in a Rigaku Mini-flux 600 diffractometer with Cu-K α radiation. The diffraction data for $V_{1-x}Ti_xAl_3$ series ($x =$

0, 0.05, 0.1, 0.2, 0.3, 0.35, 0.4, 0.5, 0.6, 0.7, 0.8, 0.9, 1) were refined by Rietveld Rietica, and the crystal parameters and atomic positions for VAL_3 and $TiAl_3$ were used as starting points. All refinements using Le Bail as the calculation method were quickly converged. The determination of the parameter a and c can completely describe the structure because all of the atoms are located in high-symmetry positions [Al(I) (0, 0, 0.5), Al(II) (0, 0.5, 0.25), and V/Ti (0, 0, 0)]. The bond length and angle were obtained by geometric relations. We also applied single-crystal XRD for the samples of $x = 0, 0.2, 0.4, 0.6, 0.8, 1$, and the results are in *SI Appendix, Tables S1–S3*. Some literature reported that the polycrystalline $TiAl_3$ transforms to a complicated superstructure at low temperature via a very sluggish and incomplete reaction (37–39). We found that our single crystals of $V_{1-x}Ti_xAl_3$ do not show any structural transition after a long time annealing at low temperature, and our XRD measurements verified that they are isostructural solid solutions. The orientations of the single crystals were determined by Laue diffraction in a Photonic Science PSL-Laue diffractometer. The compositions of V and Ti for the series were determined by energy-dispersion spectroscopy (EDS) in an X-Max 80. For the whole series, the ratio of Ti and V in the crystals is same as the starting elements of $1 - x : x$ within $\pm 2\%$ uncertainty, which is close to the estimated tolerance of the instrument ($\pm 1\%$). Since our EDS and XRD measurements have verified the homogeneity of the $V_{1-x}Ti_xAl_3$ solid solutions (40), we used the starting x as the nominal x in this paper.

Electrical and Magnetic Measurements. The resistance, Hall effect, and PHE were performed in a Quantum Design Physical Property Measurement System, using the standard four-probe technique with the silver paste contacts cured at room temperature. Temperature-dependent resistance measurement showed that the whole series are metallic (*SI Appendix, Fig. S2*) with a room-temperature resistivity ρ_{300K} approximately equaling $100 \mu\Omega\text{cm}$. In order to avoid the longitudinal resistivity contribution due to voltage-probe misalignment, the Hall resistivity was measured by sweeping the field from -9 to 9 T at various temperatures and then symmetrized as $\rho_{yx}(H) = [\rho_{yx}(+H) - \rho_{yx}(-H)]/2$. The PHE was measured in a fixed magnetic field ($\mu_0H = \pm 5$ T), and the sample was rotated so that the magnetic-field direction was kept in the plane of the current and Hall contacts. To remove the regular Hall contribution and zero-field background, we determined the planar Hall resistivity as $\rho_{yx}^{PHE}(H) = [\rho_{yx}^{PHE}(+H) + \rho_{yx}^{PHE}(-H)]/2 - \rho_{yx}^{PHE}(H=0)$. The experiment setting and data-analysis method of ρ_{yx}^{PHE} ensured that there was no contribution from the regular Hall effect and the anomalous Hall effect. The Seebeck coefficient from 300 to 100 K (*SI Appendix, Fig. S5*) was measured in a home-built thermoelectric measurement system, which used constantan as the reference. The temperature-dependent molar susceptibility and Field-dependent magnetization of VAL_3 were measured in a Superconducting Quantum Interference Device (MPMS SQUID vibrating sample magnetometer), and the relevant results are in *SI Appendix, Figs. S6 and S7*.

Electronic Calculation. The electronic structures of $TiAl_3$ and VAL_3 were calculated by using CAESAR (41) with semiempirical extended-Hückel-tight-binding methods (42). The parameters for Ti were 4s: $\zeta = 1.075$, $H_{ii} = -8.97\text{eV}$; 4p: $\zeta = 0.675$, $H_{ii} = -5.44\text{eV}$, and 3d: $H_{ii} = -10.810\text{eV}$; $\zeta_1 = 4.550$, $\text{Coefficient1} = 0.4206$; $\zeta_2 = 1.400$, $\text{Coefficient1} = 0.7839$; for V were 4s: $\zeta = 1.300$, $H_{ii} = -8.81\text{eV}$; 4p: $\zeta = 1.300$, $H_{ii} = -5.52\text{eV}$, and 3d: $H_{ii} = -11.000\text{eV}$, $\zeta = 4.750$, $\text{Coefficient1} = 0.4755$; $\zeta_2 = 1.700$, $\text{Coefficient2} = 0.7052$; and for Al were 3s: $\zeta = 1.167$, $H_{ii} = -12.30\text{eV}$; 4p: $\zeta = 1.167$, $H_{ii} = -6.50\text{eV}$. Partial DOS and COHP calculations were performed by the self-consistent, tight-binding, linear-muffin-tin-orbital method in the local density approximation and atomic sphere approximation (ASA) (43). Interstitial spheres were introduced in order to achieve space filling. The ASA radii as well as the positions and radii of these empty spheres were calculated automatically, and the values so obtained were all reasonable. Reciprocal space integrations were carried out by using the tetrahedron method. We computed electronic structures using the projector-augmented wave method (44, 45), as implemented in the VASP (46) package within the generalized gradient approximation schemes (47). A $15 \times 15 \times 15$ MonkhorstPack k-point mesh was used in the computations with a cutoff energy of 500 eV. The spin-orbital coupling effects were included in calculations self-consistently.

Data Availability

All data are contained in the manuscript text and *SI Appendix*.

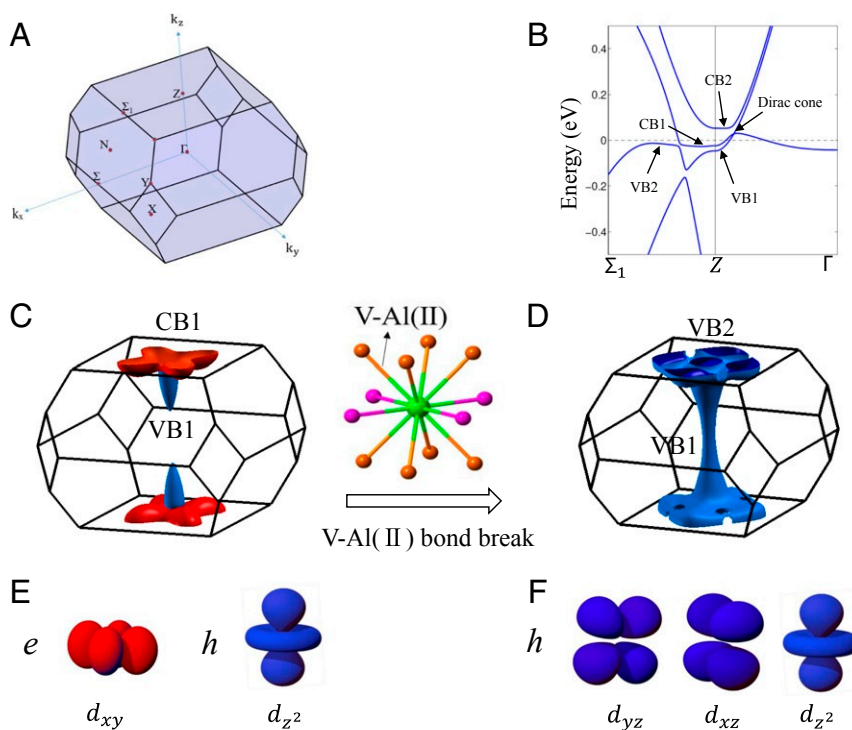


Fig. 7. (A) BZ of VAl_3 . (B) Band structure in the vicinity of the type-II Dirac node in VAl_3 . (C) Electron (CB1; red) and hole (VB1; blue) pockets of VAl_3 . (D) Hole pockets (VB1 and VB2; blue) in $\text{V}_{1-x}\text{Ti}_x\text{Al}_3$ for $x > 0.35$ as long as the V-Al(II) bond breaks. (E) d_{xy} (red) and d_{z^2} (blue) orbitals compose CB1 and VB1, respectively. (F) Degenerated d_{yz}/d_{xz} and d_{z^2} orbitals compose VB2 and VB1, respectively.

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